502308511 04/12/2013

PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Kaifeng ZHANG	11/26/2012
Takenori HIROSE	11/26/2012
Masahiro WATANABE	11/28/2012
Tsuneo NAKAGOMI	11/29/2012
Shinji HONMA	11/29/2012
Teruaki TOKUTOMI	11/29/2012
Toshihiko NAKATA	11/29/2012
Takehiro TATIZAKI	12/03/2012

RECEIVING PARTY DATA

Name:	Hitachi High-Technologies Corporation	
Street Address:	24-14, Nishi Shimbashi 1-chome	
City:	Minato-ku, Tokyo	
State/Country:	JAPAN	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	13650985

CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER: 103940.64992US

PATENT
REEL: 030202 FRAME: 0186

\$40.00 13650985

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NAME OF SUBMITTER:	Michael H. Jacobs	
Signature:	/Michael H. Jacobs/	
Date:	04/12/2013	
Total Attachments: 1 source=64992US_EXECUTED_ASGNMT#page1.tif		

PATENT REEL: 030202 FRAME: 0187

ASSIGNMENT

(譲渡証)

103940.64992US

As a below named inventor, I hereby declare that:

IN CONSIDERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me by Hitachi High-Technologies Corporation,

a corporation organized under the laws of Japan,

located at 24-14, Nishi Shimbashi 1-chome, Minato-ku, Tokyo, Japan,

receipt of which is hereby acknowledged I do hereby sell and assign to said Hitachi High-Technologies Corporation, its successors and assigns, all my right, title and interest, in and for the United States of America, in and to CANTILEVER OF SCANNING PROBE MICROSCOPE AND METHOD FOR MANUFACTURING THE

SAME, METHOD FOR INSPECTING THERMAL ASSIST TYPE MAGNETIC HEAD DEVICE AND ITS APPARATUS

invented by me (if only one is named below) or us (if plural inventors are named below) and described in the application for United States Letters Patent therefor, executed on even date herewith, and all United States Letters Patent which may be granted therefor, and all divisions, continuations and extensions thereof, the said interest being the entire ownership of the said Letters Patent when granted,

to be held and enjoyed by said Hitachi High-Technologies Corporation,

its successors, assigns or other legal representatives, to the full end of term for which said Letters Patent may be granted as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made;

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said Hitachi High-Technologies Corporation,

Signed on the date(s) indicated aside our signatures:

	INVENTOR(S) (発明者フルネームサイン)		Date Signed (署名日)
1)_	Kaifeng Thang. Kaifeng	g ZHANG	26/11/2012.
2)_	Takenori Hirose Takenori	HIROSE	26/11/2012
3)_	MasahiroWatanal MasahiroWA	TANABE	28/11/20/2
4)_	Jume Walsagown Tsuneo NA	KAGOMI	29/11/2012
		i HONMA	29/11/2012
	Jernaki Tolentomi Teruaki To	окитомі	29/11/2012
7)_	Toshihko Nahate Toshihiko	NAKATA	27/11/2012
	Takehiro Tachizaki Takehiro	ratizaki	3/12/2012
9)			
J/_			
10) _			

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RECORDED: 04/12/2013